

# PATENT ABSTRACTS OF JAPAN

(11)Publication number : 11-085880

(43)Date of publication of application : 30.03.1999

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(51)Int.Cl. G06F 19/00  
G06F 17/60

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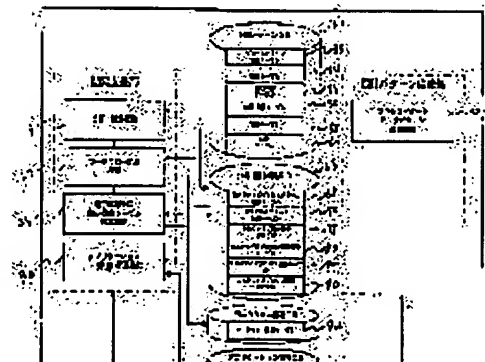
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## (54) WORK FLOW SYSTEM DEVELOPMENT SUPPORTING METHOD

### (57)Abstract:

PROBLEM TO BE SOLVED: To promote the reuse of application to use at a work flow system by providing a general-purpose frame work (design pattern) of each job, so as to support job analysis/design based on it.



SOLUTION: Information generated by a process data pattern generating function 10 is housed in a design pattern DB 33. An analyzing and designing function 15 reads data in DB 33 and houses information customized corresponding to the specification of a customer in an analyzing/designing result DB 63. A work flow defining function 20 reads information in DB 63 and houses circulating route information in a definition table. An electronic slip generating and referring/registering table preparing function 25 reads information in DB 63, houses an electronic slip and a data base in a housing areas 96 and housing destination information of the electronic slip in an application information DB 94, and updates DB 63.

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## LEGAL STATUS

[Date of request for examination] 13.09.2002

[Date of sending the examiner's  
decision of rejection] 25.10.2005

[Kind of final disposal of  
application other than the  
examiner's decision of rejection or  
application converted registration]

[Date of final disposal for  
application]

[Patent number]

[Date of registration]

[Number of appeal against  
examiner's decision of rejection]

[Date of requesting appeal against  
examiner's decision of rejection]

[Date of extinction of right]